## Interaction of laser radiation with strongly coupled xenon and krypton plasma

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The study of the optics of a dynamic object is a powerful research tool, since optical properties are very sensitive to changes in the electronic subsystem of the medium. At the same time, the correct description of collision processes in a partially ionized dense plasma is possible only on the basis of sufficient information about its optical properties. The results of new experiments on the reflection of polarized light from shock-compressed dense xenon plasma and the first experiments with krypton are presented. The study of polarized reflectivity properties of xenon plasma was accomplished using laser light of the frequency  $\nu_{\rm las} = 4.33 \times 10^{14} \ {\rm s}^{-1}$  at incident angles  $\theta = 55-78^\circ$ ,  $\nu_{\text{las}} = 5.66 \times 10^{14} \text{ s}^{-1}$  at incident angles  $\theta = 0-20^\circ$ and  $\theta = 60-78^{\circ}$ . The first experiments to study the polarization properties of a nonideal krypton plasma were performed using laser light of the frequency  $\nu_{\rm las} = 2.83 \times 10^{14} \ {\rm s}^{-1}$  at incident angles  $\theta = 0-25^{\circ}$ . The optical properties of strongly correlated xenon and krypton plasma were studied at a plasma mass density  $\rho =$ 0.83 g/cm<sup>3</sup> and  $\rho = 1.57$  g/cm<sup>3</sup>, accordingly. The composition and thermodynamic parameters of the plasma were determined using the modified Saha IV code [1].

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[1] Gryaznov V K, Iosilevskiy I L and Fortov V E 2012 AIP Conf. Proc. 917 1426